

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

WATANABE et al.

Application No. Unassigned

Art Unit: Unassigned

Examiner: Unassigned

Filed: July 28, 2003

For: METHOD OF FABRICATING X-RAY
MASK AND METHOD OF
FABRICATING SEMICONDUCTOR
DEVICE WITH X-RAY MASK
FABRICATED BY THIS METHOD

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Prior to the examination of the above-identified patent application, please enter the following amendments and consider the following remarks.